



1756/8

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q67546

Osamu NOZAWA

Appln. No.: 09/998,422

Group Art Unit: 1756

Confirmation No.: 5963

Examiner: ROSASCO, STEPHEN D

Filed: December 3, 2001

For: LITHOGRAPHY MASK BLANK AND METHOD OF MANUFACTURING THE SAME

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP NON-FEE AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated June 19, 2003, please amend the above-identified application as follows on the accompanying pages.

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